Notice of Allowability	Application No.	Applicant(s)	
	10/800,861	NAKAMURA, HIROKI	
	Examiner	Art Unit	
	YURIY SEMENENKO	2841	
The MAILING DATE of this communication app All claims being allowable, PROSECUTION ON THE MERITS IS herewith (or previously mailed), a Notice of Allowance (PTOL-85 NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT F of the Office or upon petition by the applicant. See 37 CFR 1.31	S (OR REMAINS) CLOSED in in or other appropriate commur RIGHTS. This application is sure and MPEP 1308.	his application. If not included ication will be mailed in due course. TH bject to withdrawal from issue at the init	
 ∑ The allowed claim(s) is/are 30,31 and 33-39. 	<u> </u>	<u>-</u>	
3.	re been received. re been received in Application	No	e
* Certified copies not received:			
Applicant has THREE MONTHS FROM THE "MAILING DATE noted below. Failure to timely comply will result in ABANDON! THIS THREE-MONTH PERIOD IS NOT EXTENDABLE. 4. A SUBSTITUTE OATH OR DECLARATION must be subr INFORMAL PATENT APPLICATION (PTO-152) which give	MENT of this application. mitted. Note the attached EXAI	MINER'S AMENDMENT or NOTICE OF	
5. CORRECTED DRAWINGS (as "replacement sheets") mu	ist he submitted		
(a) ☐ including changes required by the Notice of Draftsper		(PTO-948) attached	
1) hereto or 2) to Paper No./Mail Date	-	(1.10.010) allasiisa	
(b) ☐ including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR)	's Amendment / Comment or i	drawings in the front (not the back) of	
each sheet. Replacement sheet(s) should be labeled as such in 6. DEPOSIT OF and/or INFORMATION about the deposit attached Examiner's comment regarding REQUIREMENT	osit of BIOLOGICAL MATE	RIAL must be submitted. Note the	
Attachment(s) 1. ☐ Notice of References Cited (PTO-892) 2. ☐ Notice of Draftperson's Patent Drawing Review (PTO-948) 3. ☑ Information Disclosure Statements (PTO/SB/08), Paper No./Mail Date 04/03/2009 4. ☐ Examiner's Comment Regarding Requirement for Deposit of Biological Material	6. ⊠ Interview Sur Paper No./N 7. □ Examiner's A	rmal Patent Application nmary (PTO-413), lail Date <u>06/29/2009</u> . mendment/Comment tatement of Reasons for Allowance	
/Y. S./			
Examiner, Art Unit 2841			

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DETAILED ACTION

Response to Amendment

1. Amendment filed on 03/23/2009 has been entered.

Claims 30, 31, 33-39 are now pending in the application.

Information Disclosure Statement

2. The references cited in the information disclosure statements (IDS) filed on 04/03/2009 have been considered by the examiner. An initialed and dated copy of Applicant's IDS form 1449, is attached to the instant Office action.

Claims

3. Claims 30, 35, 37 and 39 amendments, filed on 03/23/2009 are considered and acknowledged. The claims amendments are approved.

Response to Arguments

4. Applicant's arguments filed 03/23/2009 have been fully considered and they are persuasive.

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Allowable Subject Matter

5. Claims 30-31, 33-34 and 35-39 are allowed.

The following is a statement of reasons for the indication of allowable subject matter of the claims 30-31 and 33-34: The limitations "an island-shaped silicon layer which is provided on an insulating substrate ...the copper seed layer and the copper layer are surrounded by the first copper diffusion-preventing layer and the second copper diffusion-preventing layer, and have a forward tapered cross section" in combination with other claimed limitations in independent claim 30 is not disclosed or suggested by the prior art of record. Claims 31 and 33-34 are either directly or indirectly dependent upon claim 30.

The following is a statement of reasons for the indication of allowable subject matter of the claims 35 and 36: The limitations "the gate electrode comprises source electrode and the drain electrode comprise: a first copper diffusion-preventing layer formed on the gate insulator layer source region and the drain region ... the organometallic compound material layer and the copper layer have a forward tapered cross section and are surrounded by the first copper diffusion-preventing layer and the second copper diffusion-preventing layer "in combination with other claimed limitations in independent claim 35 is not disclosed or suggested by the prior art of record. Claim 36 is dependent upon claim 35.

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The following is a statement of reasons for the indication of allowable subject matter of the claims 37 and 38: The limitations "an island-shaped silicon layer which is provided on an insulating substrate ... a second copper diffusion-preventing layer covering an exposed surface including side and upper surfaces of a multilayered structure having the first copper diffusion-preventing layer, the copper layer, and the copper seed layer, and wherein the copper layer has a forward tapered cross section " in combination with other claimed limitations in independent claim 37 is not disclosed or suggested by the prior art of record. Claim 38 is dependent upon claim 37. The following is a statement of reasons for the indication of allowable subject matter of the claim 39: The limitations "a silicon layer which is provided on an insulating substrate ... a first copper diffusion-preventing layer formed on the source region and the drain region ... the nickel seed layer or a seed layer made of a metal material of group VIIIa including a cobalt seed layer and the copper layer are surrounded by the first copper diffusion-preventing layer and the second copper diffusion-preventing layer, and have a forward tapered cross section "in combination with other claimed limitations in independent claim 39 is not disclosed or suggested by the prior art of record.

6. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Yuriy Semenenko whose telephone number is (571) 272-6106. The examiner can normally be reached on 8:30am - 5:00pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Dean A. Reichard can be reached on (571)- 272-2800 ext. 31. The fax

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phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free). If you would like assistance from a USPTO Customer Service Representative or access to the automated information system, call 800-786-9199 (IN USA OR CANADA) or 571-272-1000.

/Y. S./ /Dean A. Reichard/

Examiner, Art Unit 2841 Supervisory Patent Examiner, Art

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